

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Mitsugu ABE, et al.

SERIAL NO: 10/549,294

GAU: 3727

FILED: September 16, 2005

EXAMINER: ROSE, R.

FOR: MATERIAL FOR PURIFICATION OF SEMICONDUCTOR POLISHING
SLURRY, MODULE FOR PURIFICATION OF SEMICONDUCTOR
POLISHING SLURRY AND PROCESS FOR PRODUCING SEMICONDUCTOR
POLISHING SLURRY

REQUEST FOR EXTENSION OF TIME
UNDER 37 C.F.R. 1.136

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

It is hereby requested that a **one** month extension of time be granted to June 6, 2009 for

- ☐ filing a response to the Official Action dated:
- ☐ responding to the requirements in the Notice of Allowability dated:
- ☐ filing the Formal Drawings. The Issue Fee due has been timely filed.
- ☐ responding to the Notice to File Missing Parts of Application dated:
- ☒ filing a Notice of Appeal. A Request for Continued Examination (RCE) with an Amendment is being filed in lieu of a Notice of Appeal.
- ☐ filing an Appeal Brief. A Notice of Appeal was filed on:
- ☐ Applicant claims small entity status. See 37 CFR 1.27.

The required fee of \$130.00 is being made by credit card payment online (if electronically filed), or is attached hereto (if paper filed), and any further charges may be made against the Attorney of Record's Deposit Account No. 15-0030.

Customer Number

22850

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Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.
Norman F. Oblon



Corwin P. Umbach, Ph.D.
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